

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Takeshi Nakamura et al. Art Unit : 3729  
Serial No. : 10/598,469 Examiner : Minh Trinh  
Filed : May 17, 2007 Conf. No. : 5820  
Title : MULTILAYER SUBSTRATE MANUFACTURING METHOD

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JANUARY 23, 2009

Please amend the above-identified application as follows: